## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF:

Jaehwan EUN, et al.

**CONFIRMATION NO.: 1957** 

FILED: June 17, 2005

**GROUP ART UNIT:** 

SERIAL NO. 10/539,883

**EXAMINER:** 

FOR: Method For Preparation of Ferroelectric Single Crystal Film Structure Using

Deposition Method

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SIR:

This Information Disclosure Statement is being filed in accordance with the provisions of 37 CFR 1.97 before the issuance of a first Office Action. However, any required fees in the prosecution of this application should be deducted from Deposit Account No. 503814.

The Information Disclosure Statement is being filed to officially make of record the references, with English abstracts thereof, cited in the attached PTO/SB/08A attached hereto.

Respectfully submitted,

Attorney for Applicant

Dated: March 14, 2007

Eugéne Lieberstein Registration No. 24,645

CUSTOMER NO.: 01109

## **MAILING CERTIFICATE**

I hereby certify that this IDS w/References & English abstracts, is being deposited with the Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 via EFS-Web on March 75, 2007.

Signed:

July de fy Kudrey de Souza

PTO/SB/08A (09-06)

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of information unless it contains a valid OMB control number.

Substitute for form 1449/PTO		Complete if Known				
		Application Number	10/539,883			
	ATION DISCLOSURE	Filing Date	June 17, 2005			
INFORMATION DISCLOSURE		First Named Inventor	Jaehwan EUN, et al.			
STATEM	ENT BY APPLICANT	Art Unit				
(Use as many sheets as necessary)		Examiner Name				
ot 11	of 1	Attorney Docket Number	DE1642			

Sheet 1 U. S. PATENT DOCUMENTS Pages, Columns, Lines, Where **Publication Date** Name of Patentee or Document Number Examiner Cite Relevant Passages or Relevant MM-DD-YYYY Applicant of Cited Document Initials' No Figures Appear Number-Kind Code<sup>2 (Fkoom)</sup> US-US-US-US-US-US-US-US-US-US-US-US-US-118-110 US-US-US-

Examiner Cite	Foreign Patent Document	FOREIGN PATENT DOCUMENTS  lign Patent Document Publication Ne Date Applic		Pages, Columns, Lines, Where Relevant Passages	7-6
	 Country Code <sup>3</sup> "Number <sup>4</sup> "Kind Code <sup>5</sup> (# known)	MM-DD-YYYY		Or Relevant Figures Appear	Τ,
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Examiner Signature	Date Considered	

\*\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. \*Applicant's unique citation designation number (optional). \*See Kinds Codes of USPTO Patent Documents at <a href="https://www.usca.com">www.usca.com</a> on MPEP 901.04. \*Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). \*For Japanese patent documents, the indication of the year of the region of the Emperor must precede the serial number of the patent document. \*Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. \*Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Office, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450, DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.